

Patent # 2,304,661

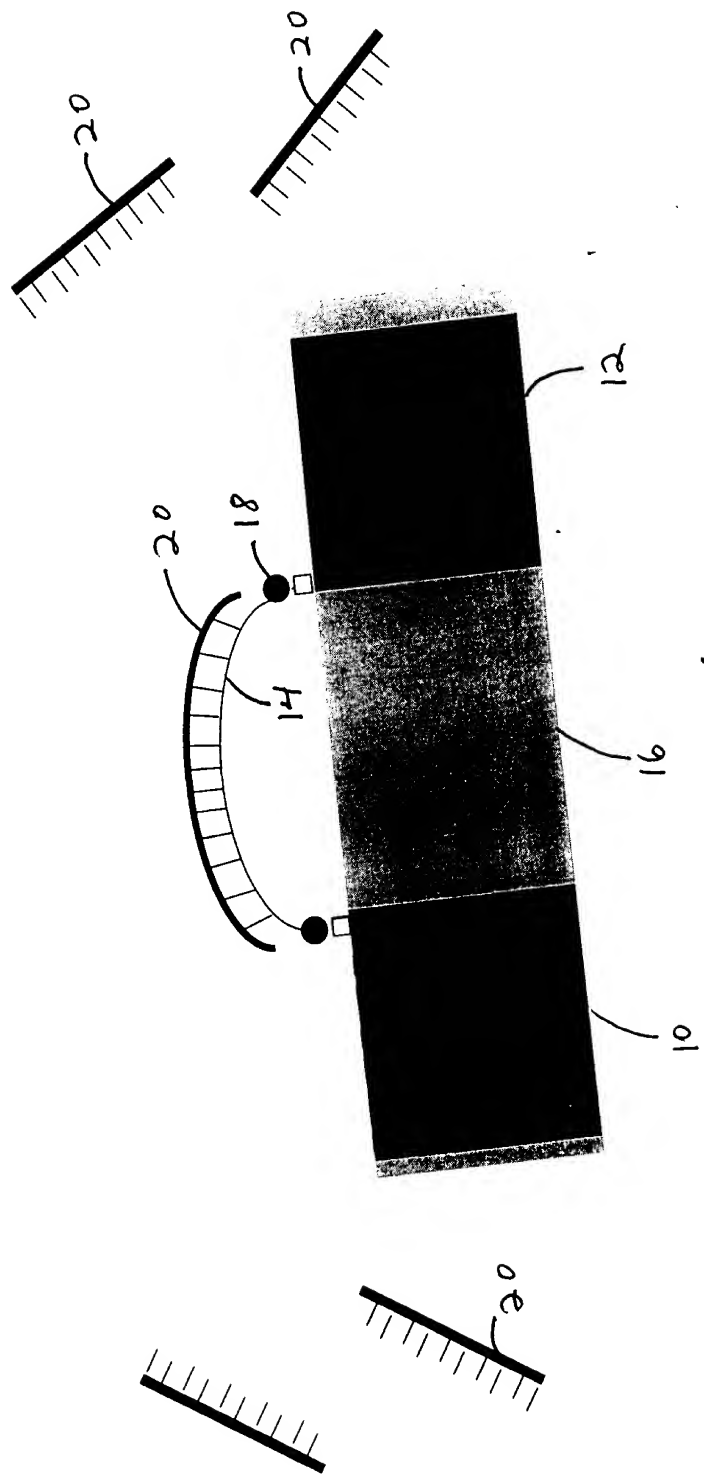


Fig. 1

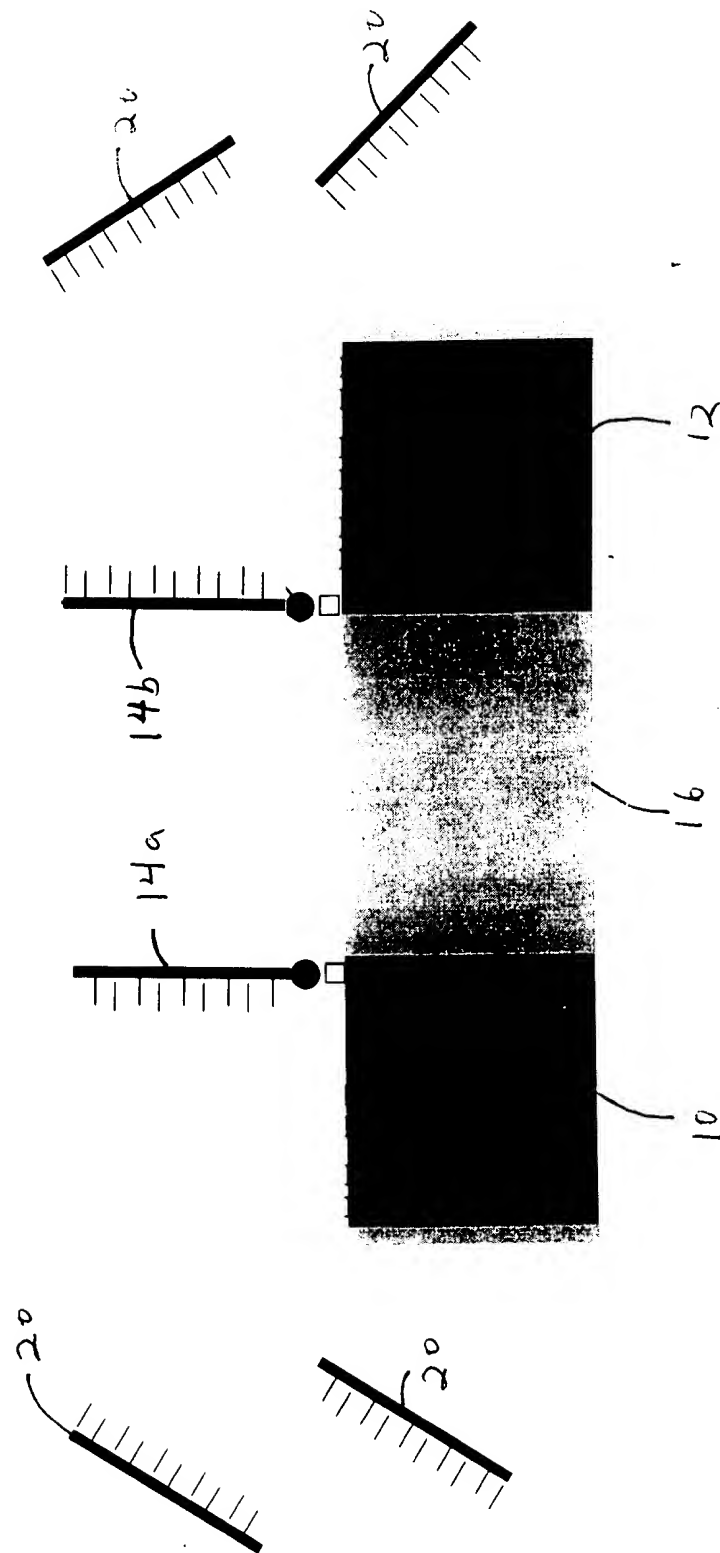


Fig. 2A

FIG. 2B

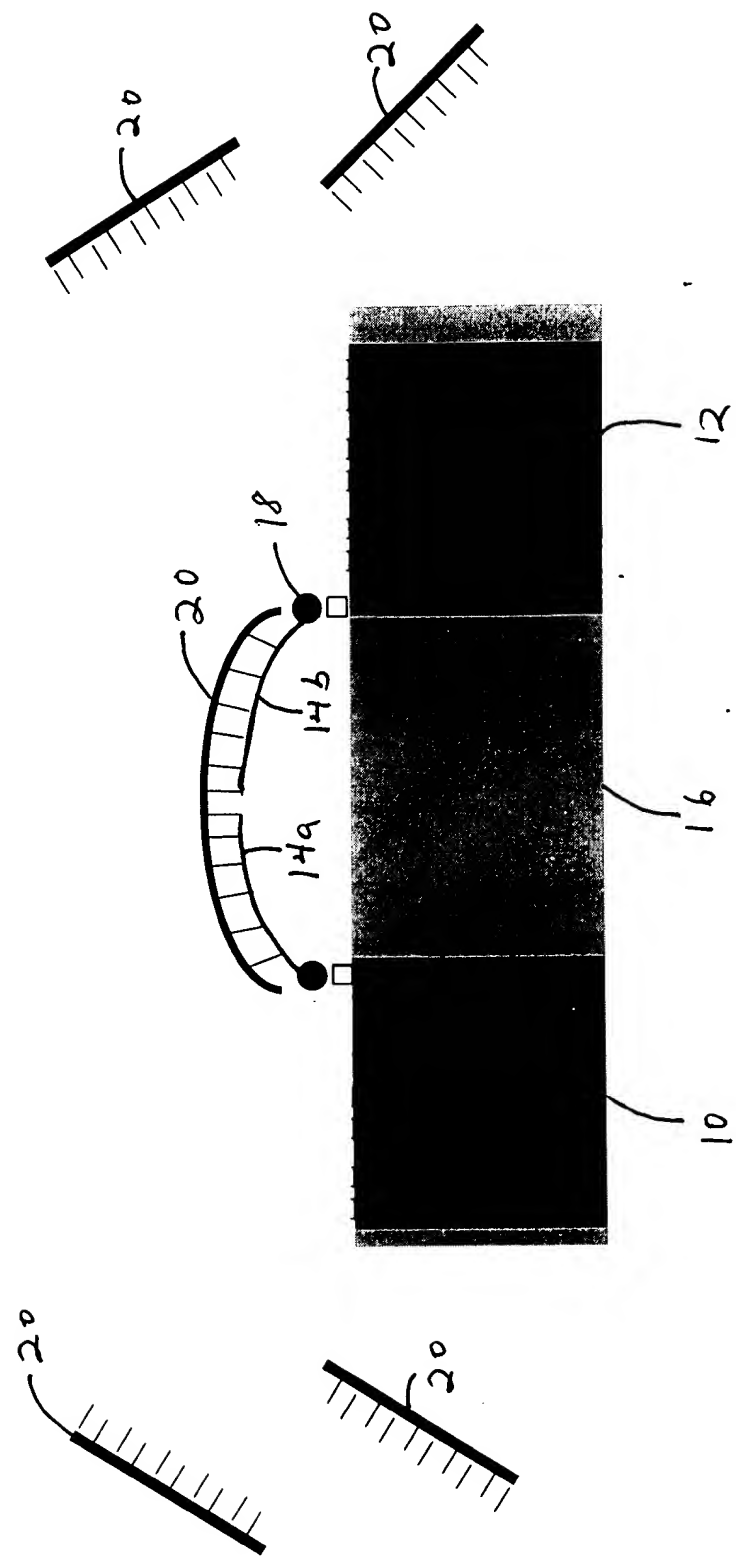
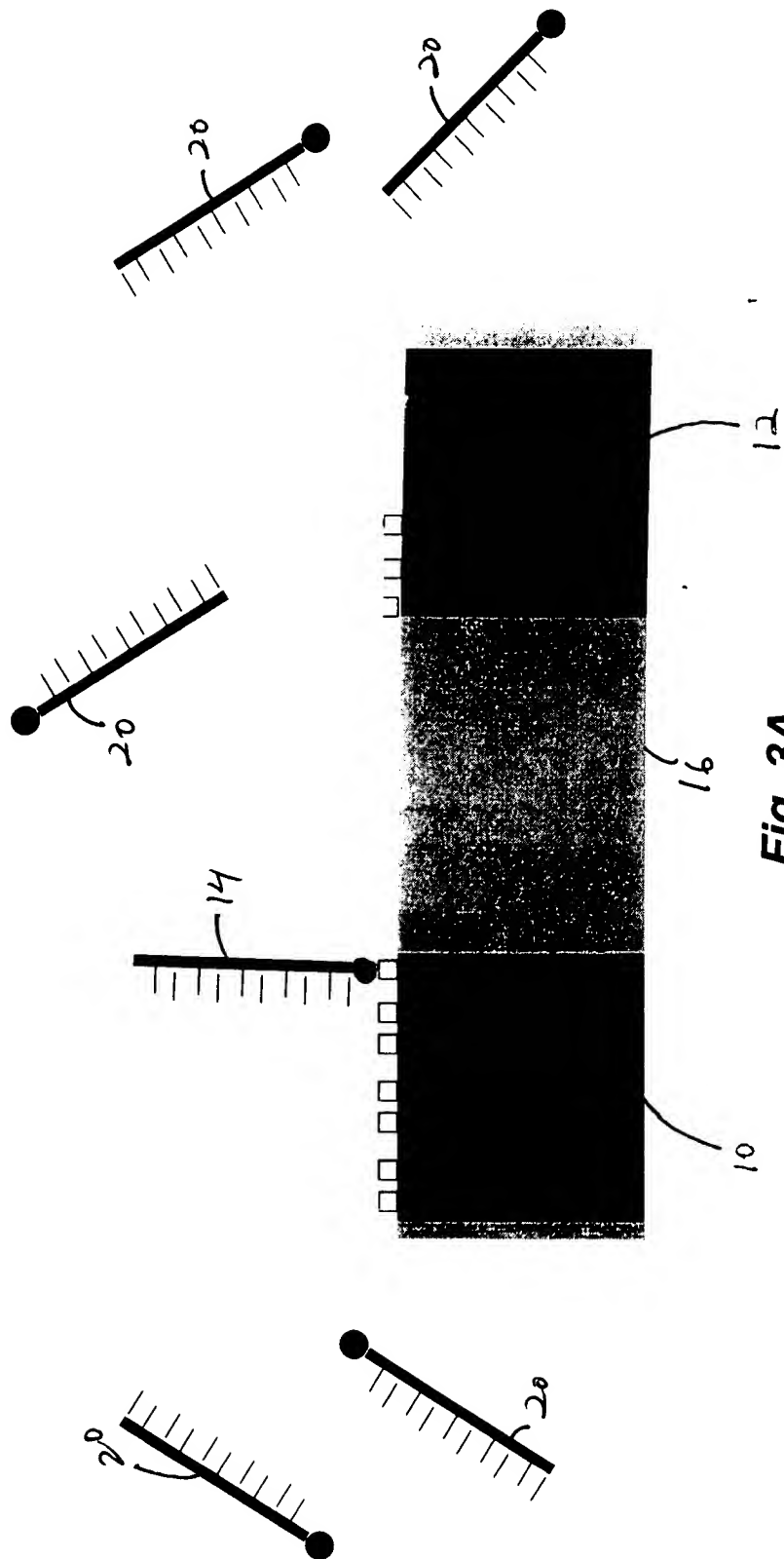


Fig. 2B



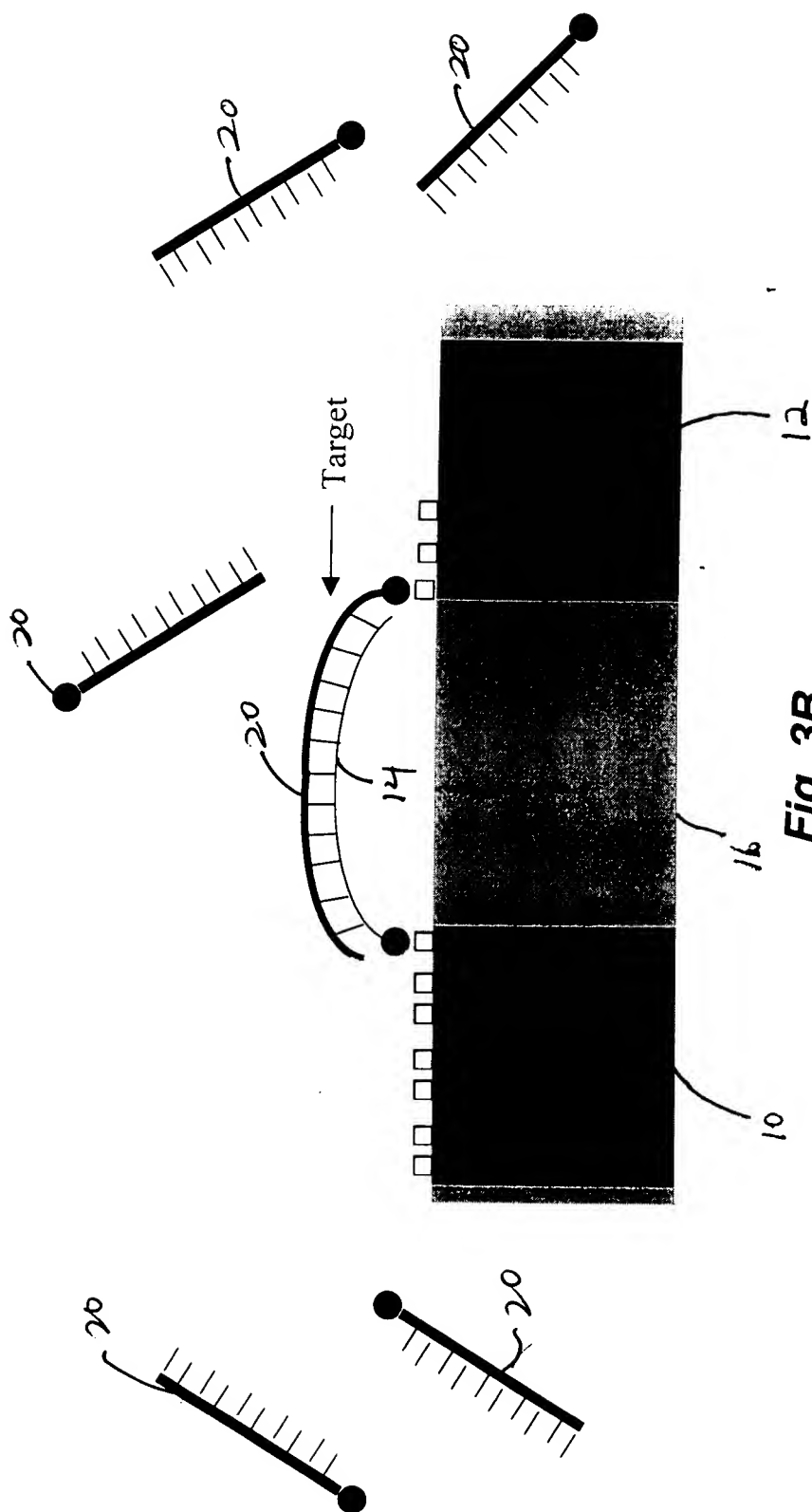
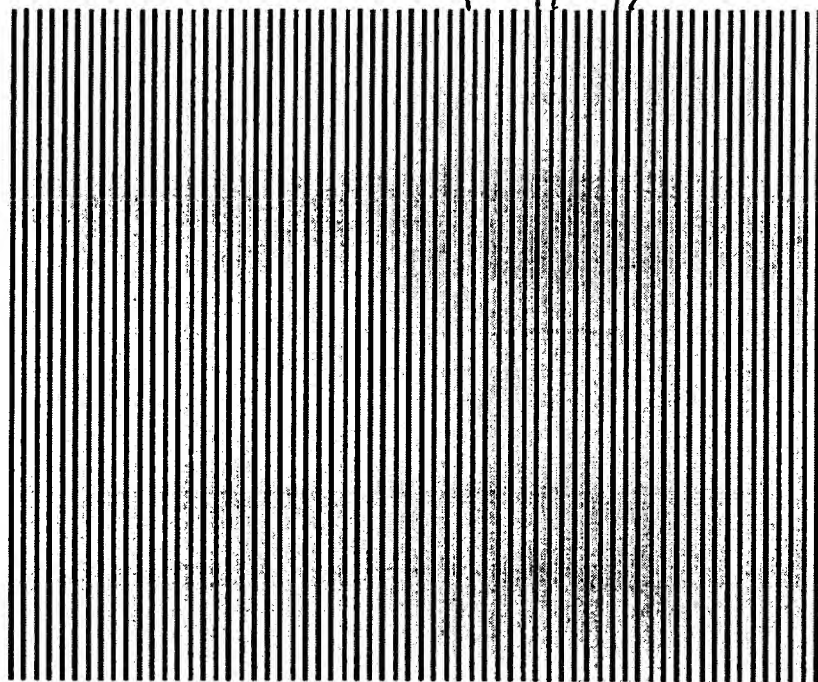


Fig. 3B

FIG. 4A

↓ Assay Flow



Alternative  
Assay Flow



*Fig. 4A*

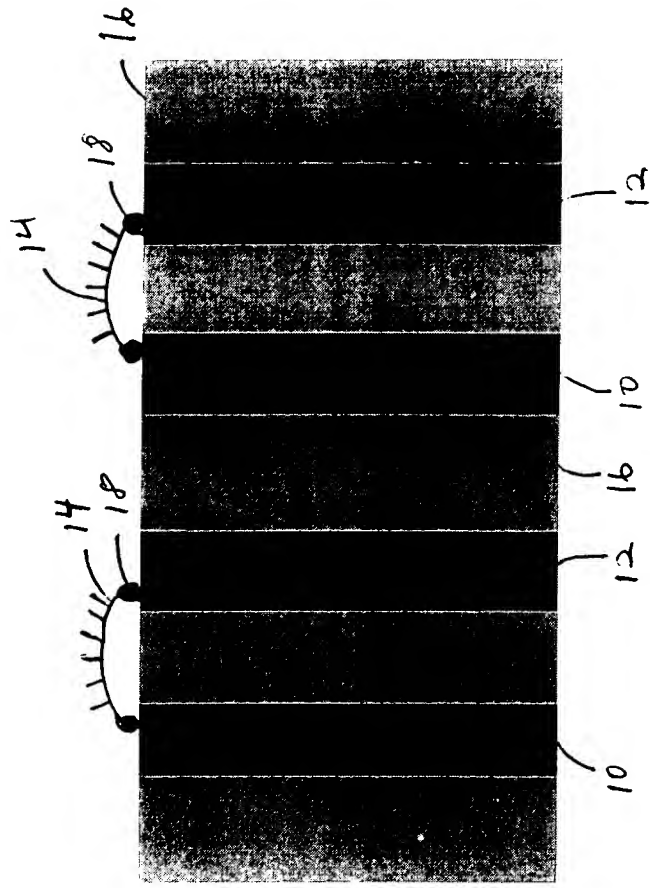


Fig. 4B

FIG. 5

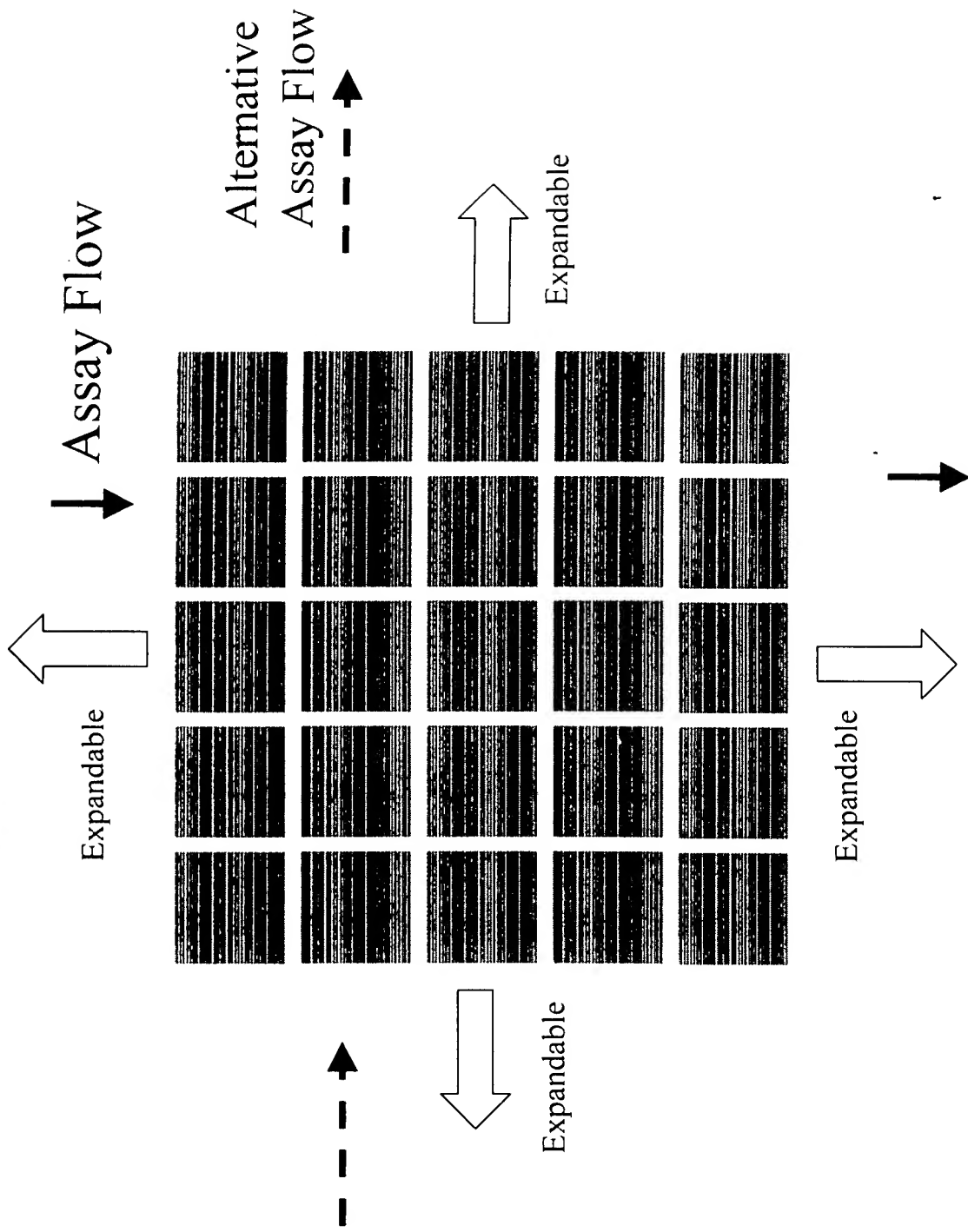


Fig. 5



FIG. 6A

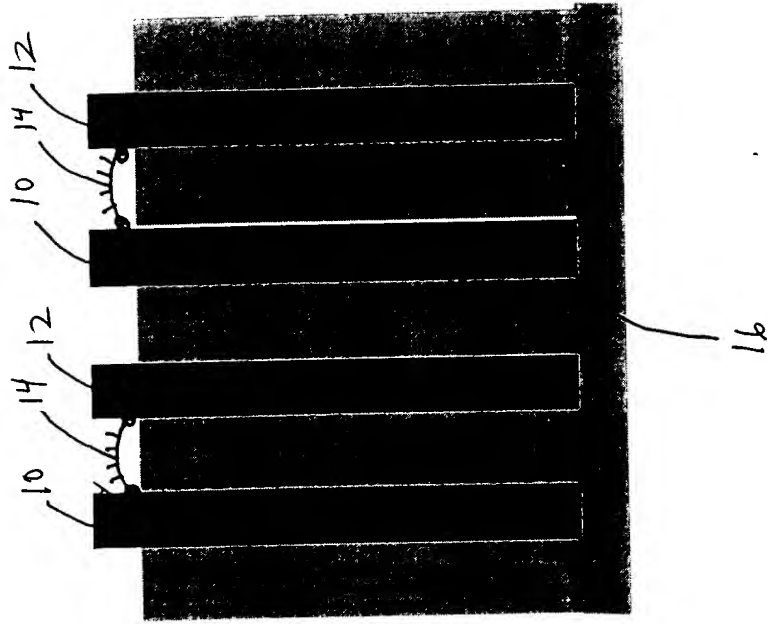


Fig. 6A

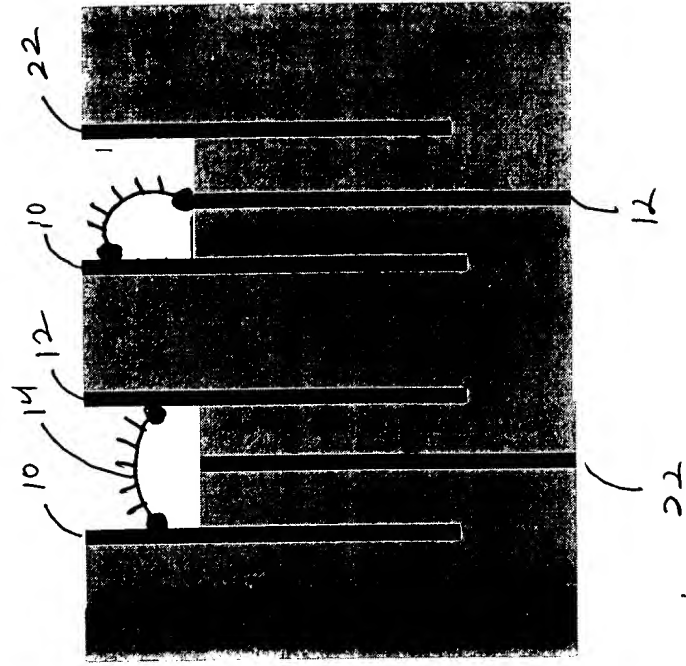


Fig. 6B

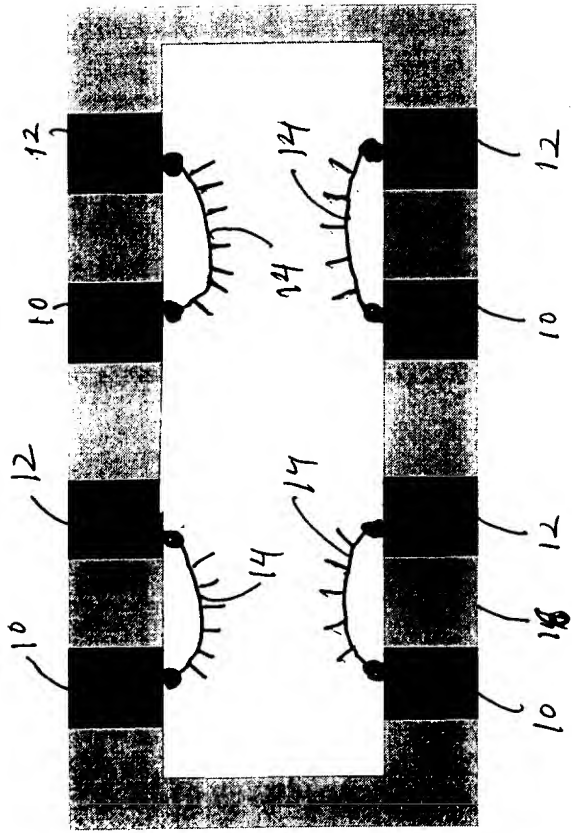


Fig. 6C

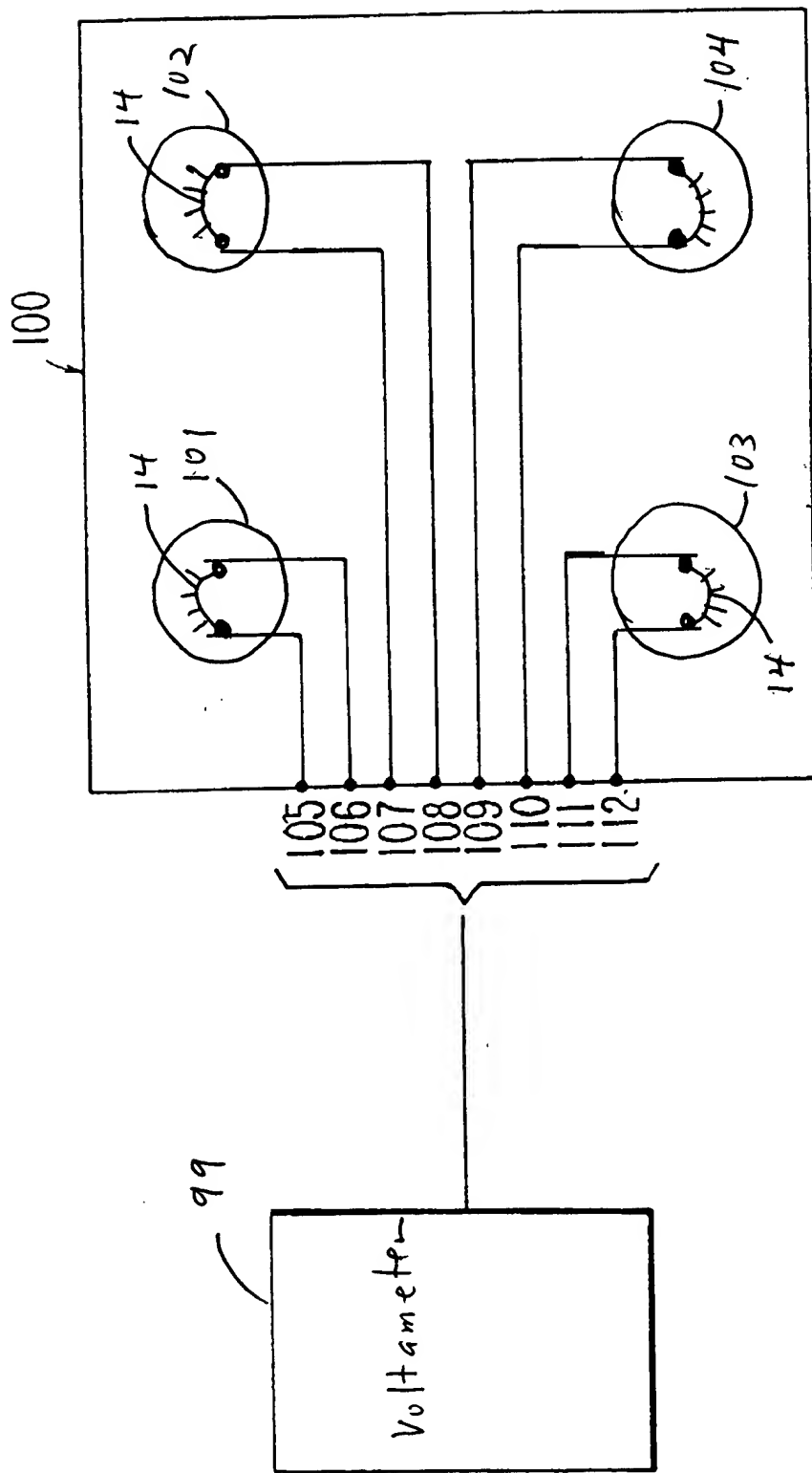


Fig. 7

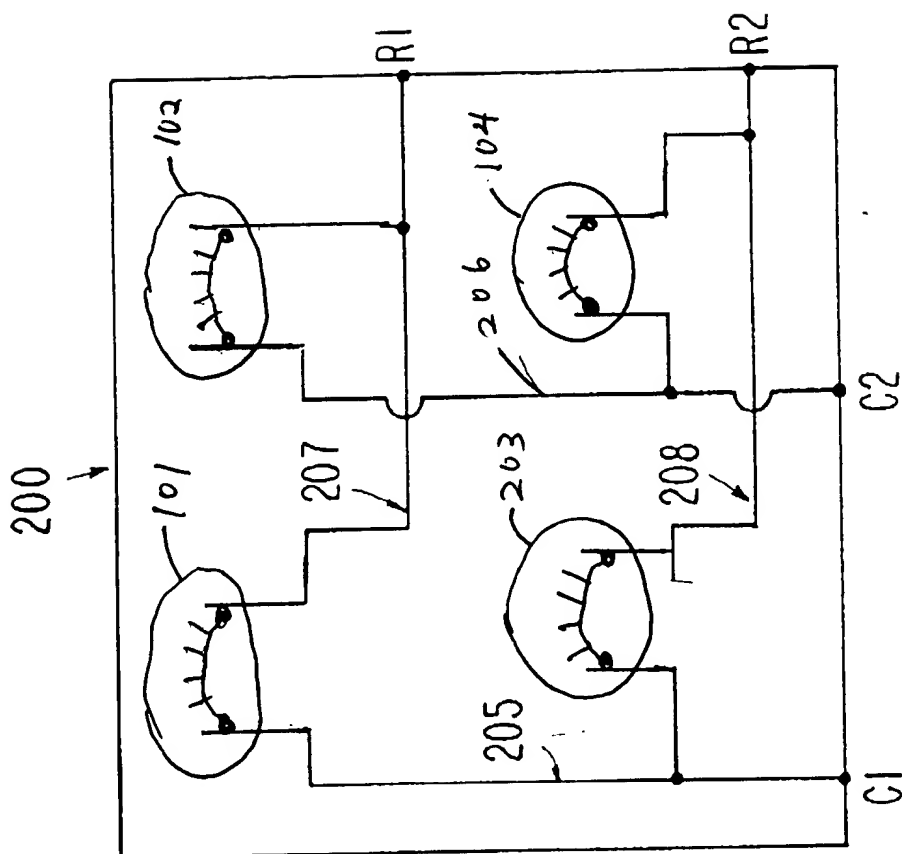


Fig. 8

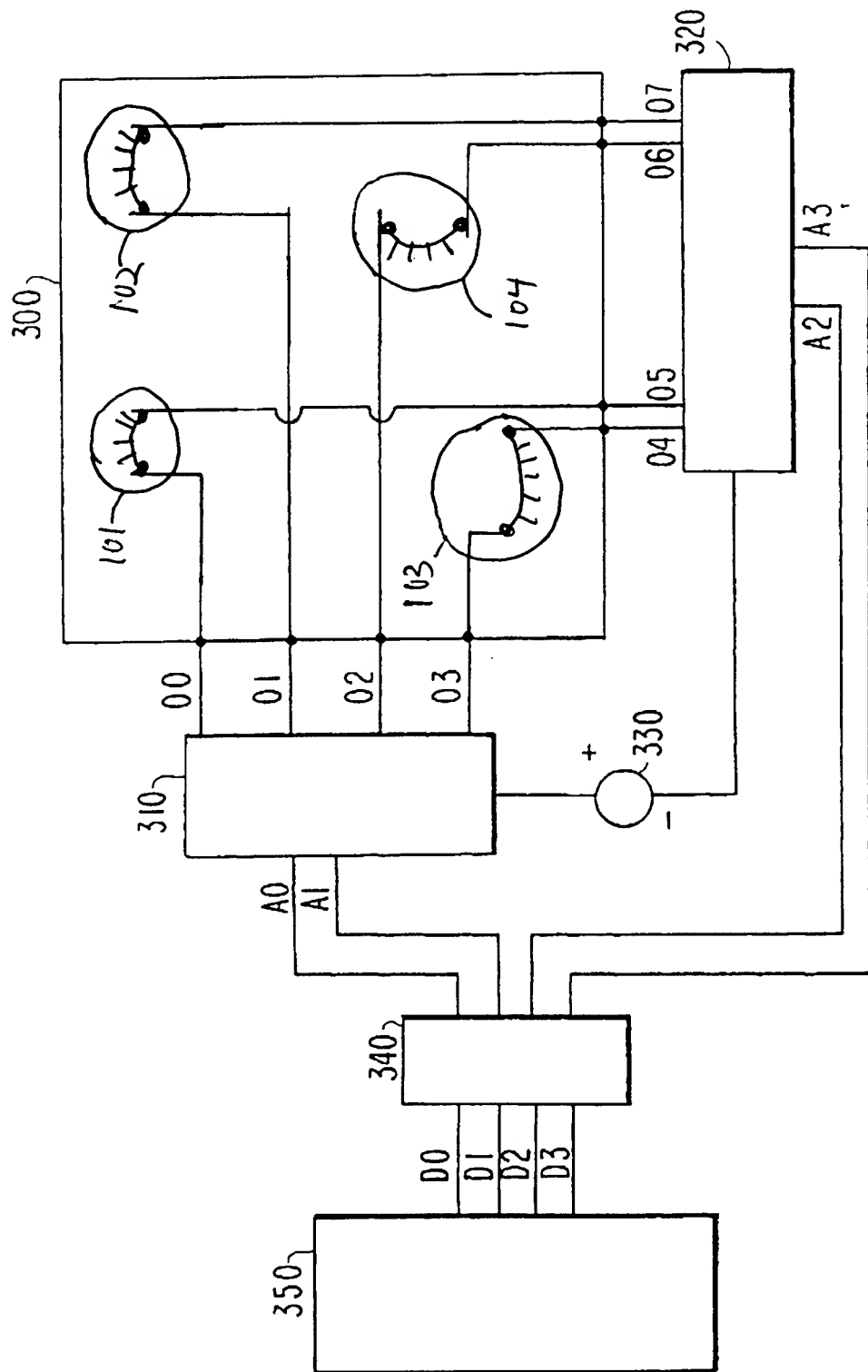
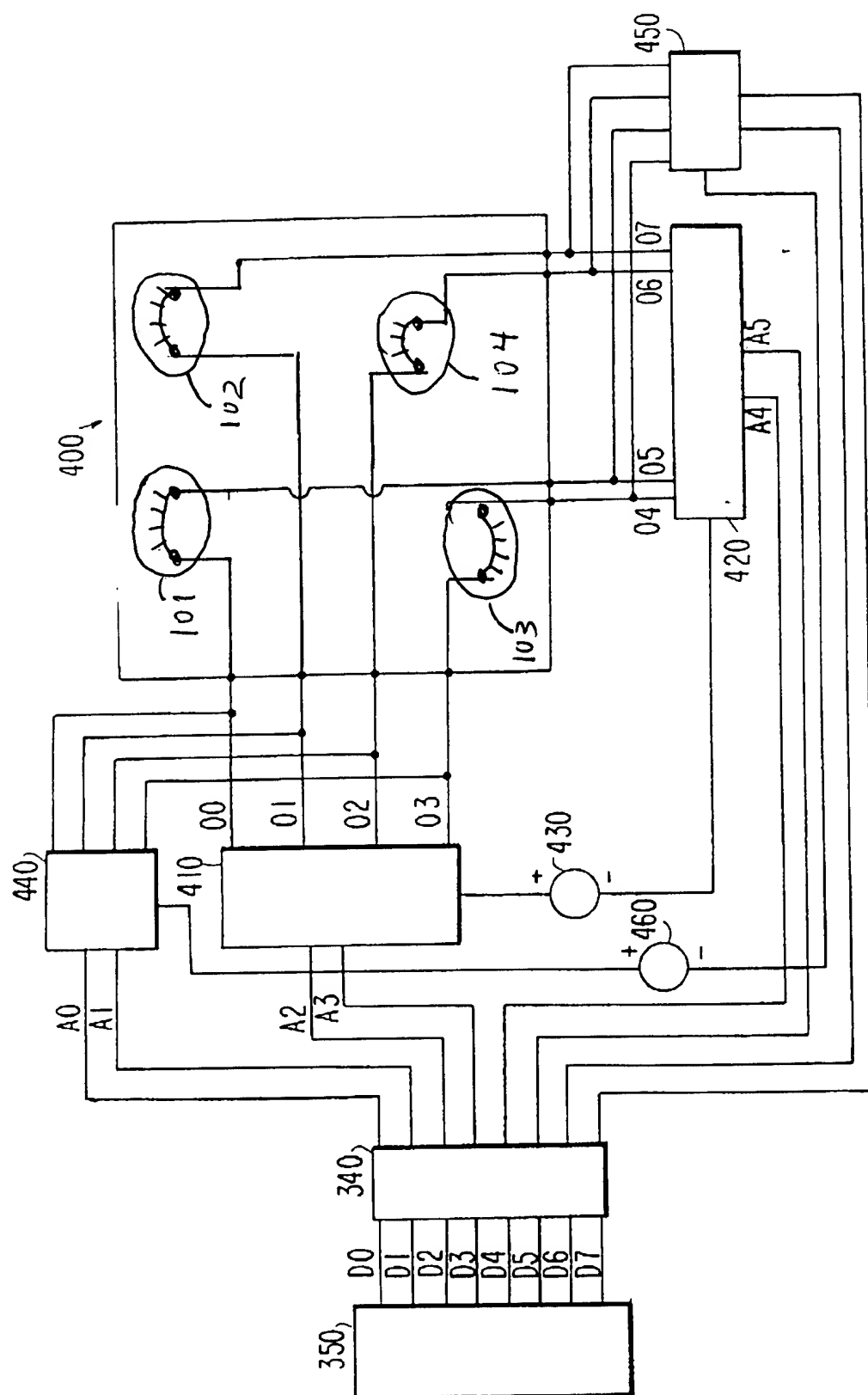


Fig. 9

**09-07-2006**



**Fig. 10**

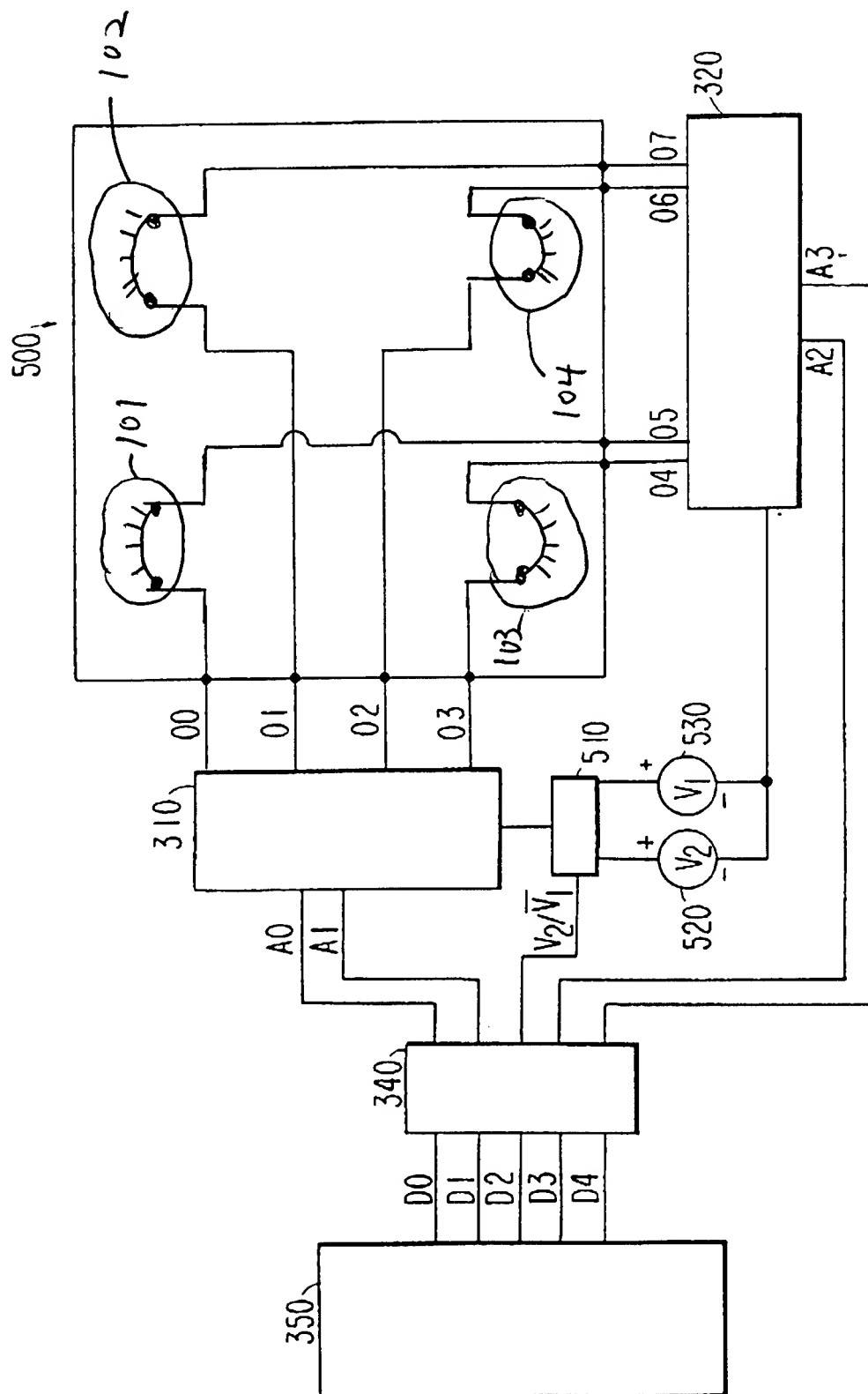
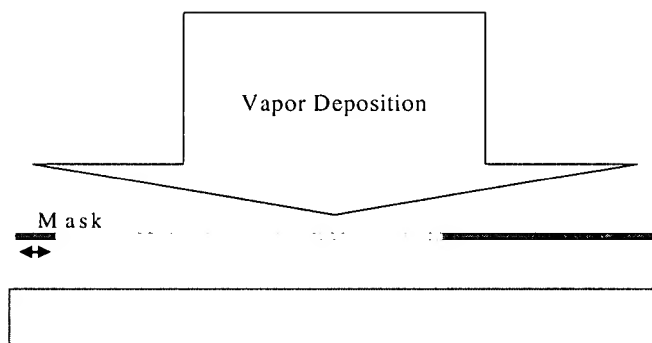
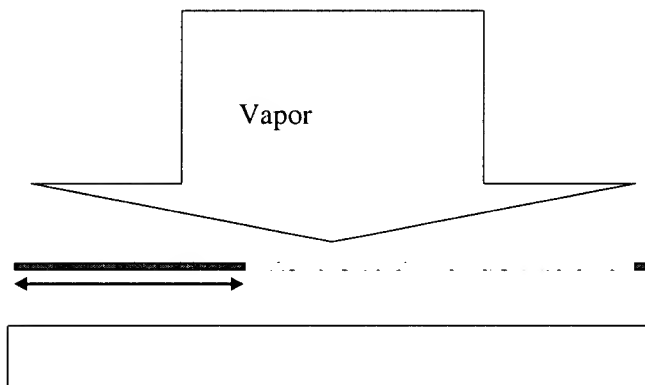


Fig. 11



Conductor 1 position deposition mask

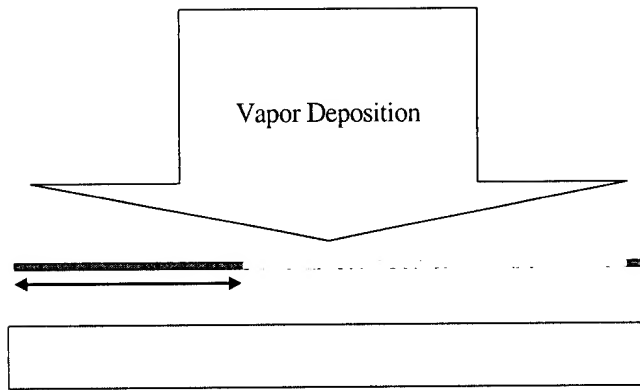
**Fig. 12A**



Conductor 2 position deposition

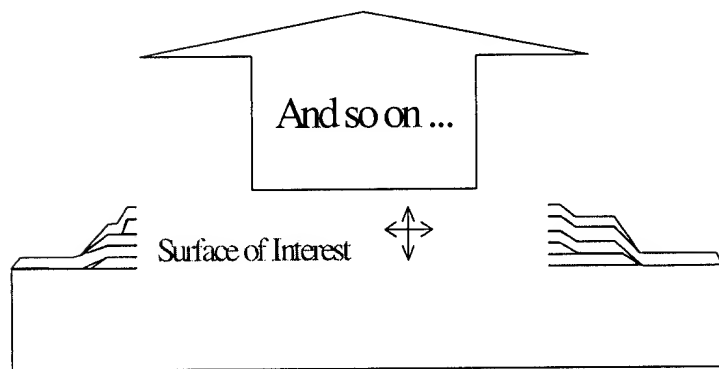
**Fig. 12B**





Conductor 2 position deposition mask

**Fig. 12C**



**Fig. 12D**

FIG. 13

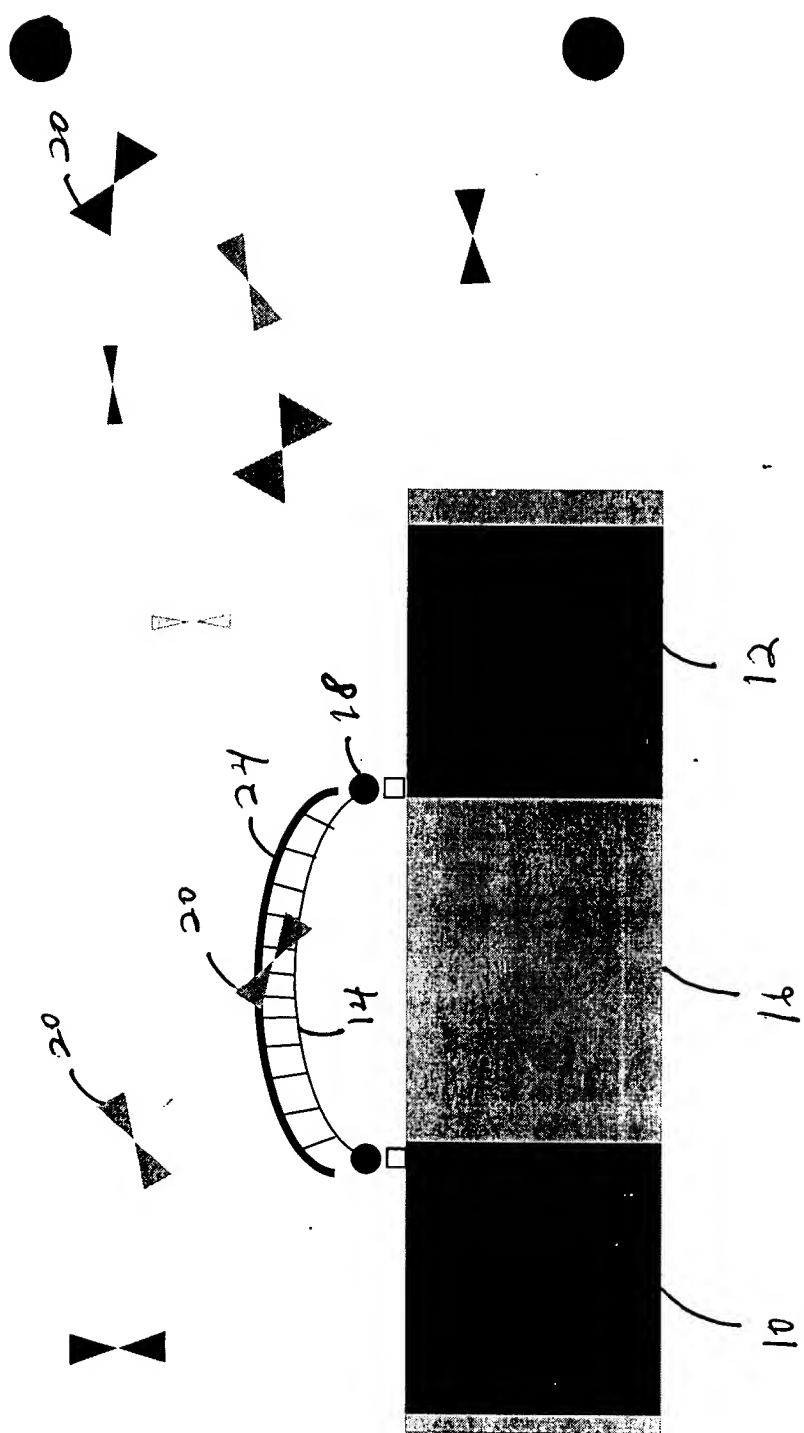


Fig. 13